t No. AM-2602

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ion of:

Jeng H. Hwang et al.

Serial No.: 10/057,674

Filed: January 24, 2002

MASKING METHODS AND ETCHING

SEQUENCES FOR PATTERNING ELECTRODES

OF HIGH DENSITY RAM CAPACITORS

Group Art Unit: 1756

Examiner: N. Barreca

Attorney Docket No.:

AM-2602.C1

Date: June 18, 2003

PETITION FOR EXTENSION OF TIME

Hon. Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This is a petition for a <u>one-month</u> extension of the time to file a response to the 1. Office Action mailed March 14, 2003 in the subject patent application. The due date for the response was June 16, 2003, and the present one month extension of time will provide for a response through July 14, 2003.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper and documents accompanying this paper are being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU497709224US in an envelope addressed to: Mail Stop Amendment (With Fee), Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 18, 2003 Date:

Shirley **L**. Church, Reg. No. 31,858

06/20/2003 WASFAW1 00000093 10057674

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110.00 DP

2.	Extension:	Length of Extension		Fee Under 37 CFR § 1.17
		<u>X</u>	One-Month	\$110.00
		_	Two-Month	\$410.00
			Three-Month	\$930.00
			Four-Month	\$1,450.00

3. The accompanying transmittal letter shows this fee of \$ 110.00 for the one-month extension of time. The transmittal letter is submitted in duplicate for accounting purposes.

Respectfully Submitted,

Shirley V. Church

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